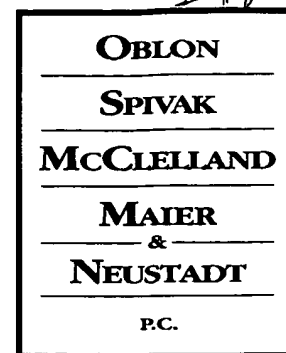




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ALEXANDRIA, VIRGINIA 22313



ATTORNEYS AT LAW

NORMAN F. OBLON
(703) 413-3000
NOBLON@OBLON.COM

VINCENT K. SHIER, PH.D.
SENIOR ASSOCIATE
(703) 413-3000
VSHIER@OBLON.COM

RE: Application Serial No.: 10/713,054
Applicants: Masanobu OGINO, et al.
Filing Date: November 17, 2003
For: SEMICONDUCTOR SUBSTRATE AND METHOD
OF MANUFACTURE THEREOF
Group Art Unit: 2813
Examiner: NGUYEN, T. T.

SIR:

Attached hereto for filing are the following papers:

REQUEST FOR RECONSIDERATION

Our credit card payment form in the amount of -0- is attached covering any required fees. In the event any variance exists between the amount enclosed and the Patent Office charges for filing the above-noted documents, including any fees required under 37 C.F.R. 1.136 for any necessary Extension of Time to make the filing of the attached documents timely, please charge or credit the difference to our Deposit Account No. 15-0030. Further, if these papers are not considered timely filed, then a petition is hereby made under 37 C.F.R. 1.136 for the necessary extension of time. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.
Norman F. Oblon

Vincent K. Shier, Ph.D.
Registration No. 50,552

Customer Number

22850

(703) 413-3000 (phone)
(703) 413-2220 (fax)